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**STUDY OF THE POTENTIAL OF MAIN-BEAM  
NULLING WITH AN OVERLAPPED-SUBARRAY  
ANTENNA**

Ronald L. Fante

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APPROVED:



WALTER ROTMAN, Chief  
Antennas and RF Components Branch  
Electromagnetic Sciences Division

APPROVED:



ALLAN C. SCHELL, Chief  
Electromagnetic Sciences Division

FOR THE COMMANDER:



JOHN P. HUSS  
Acting Chief, Plans Office

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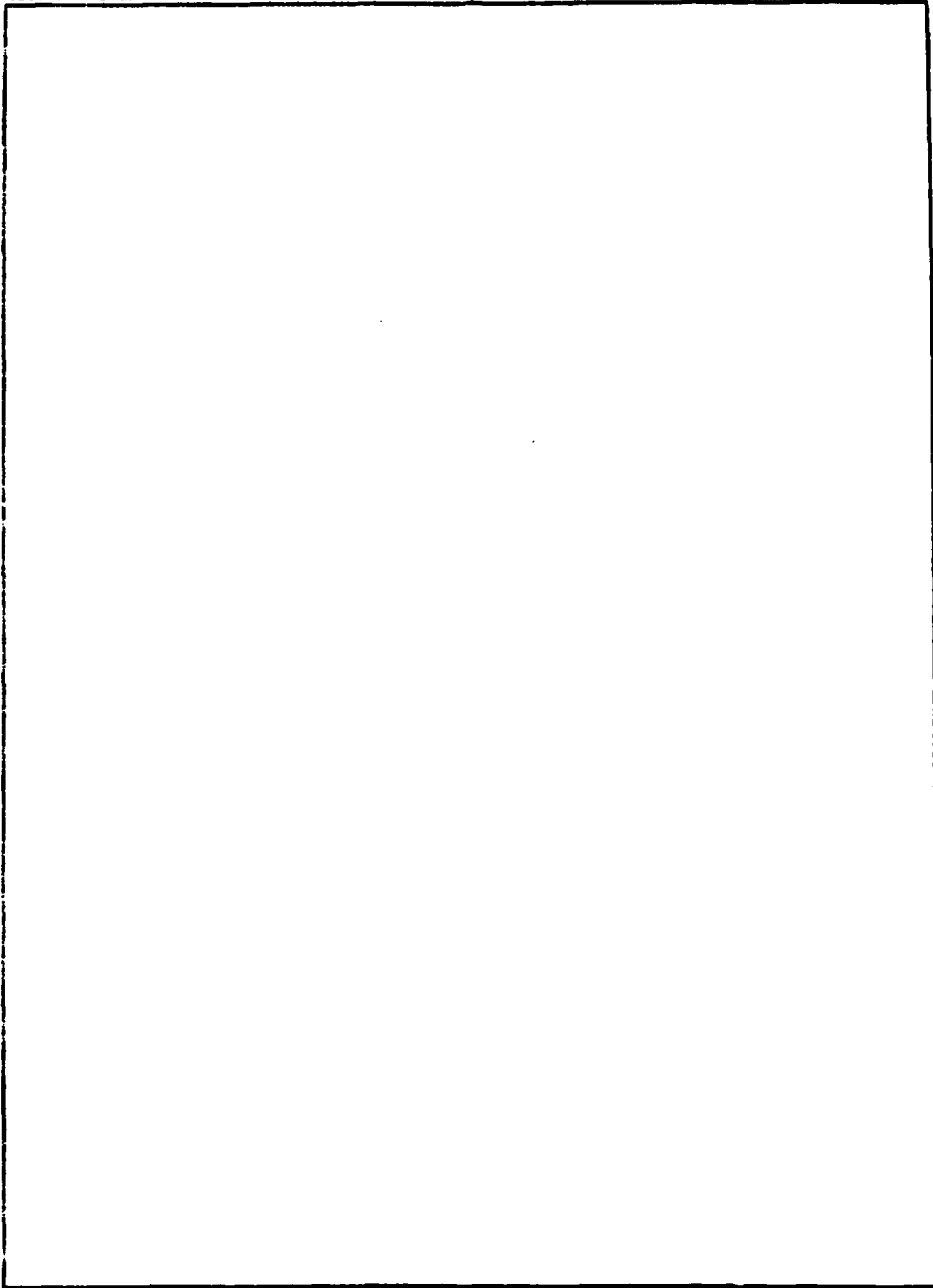
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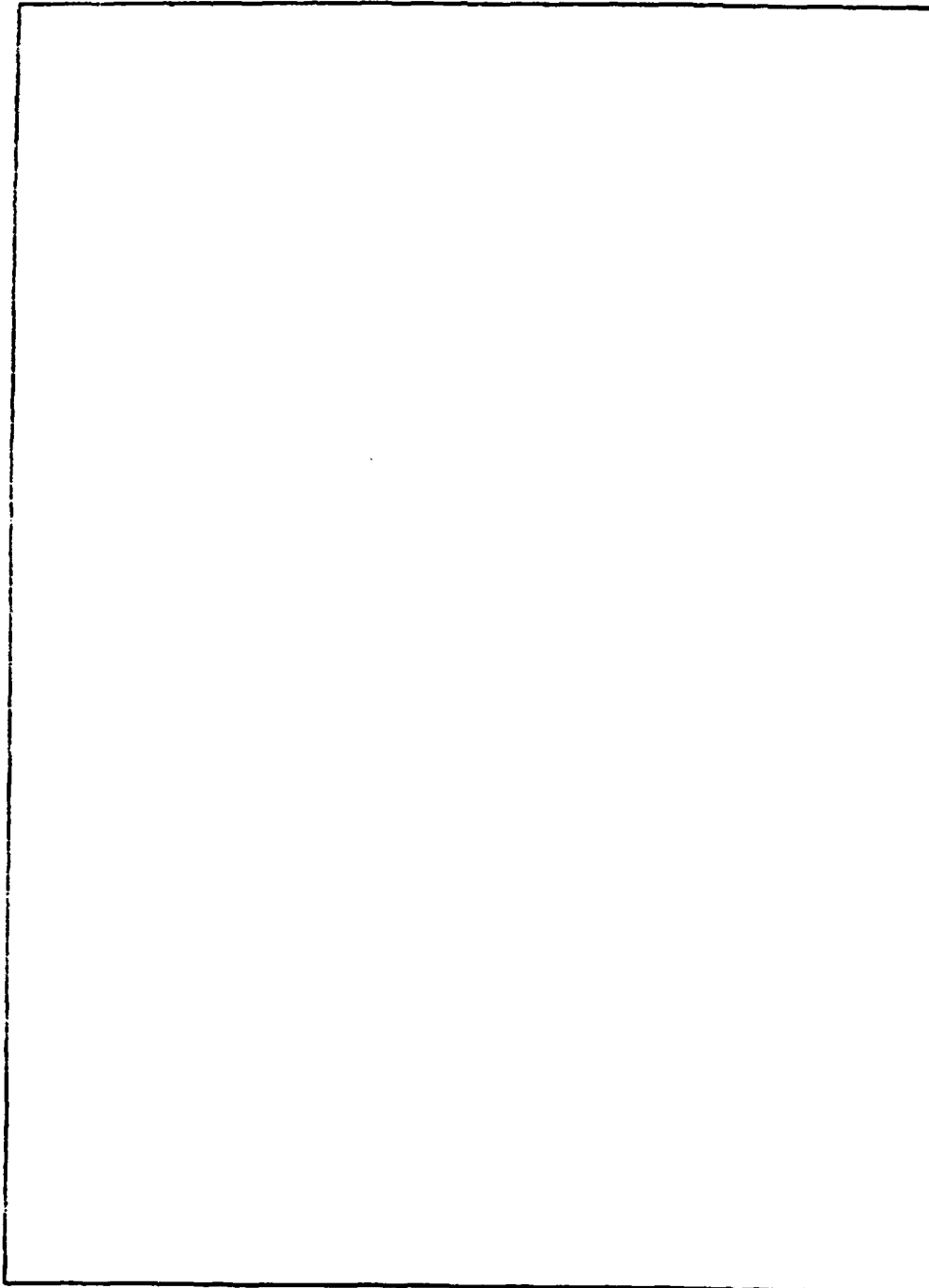
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## Study of the Potential of Main-Beam Nulling With an Overlapped-Subarray Antenna

### 1. INTRODUCTION

In this report we will present the results of our study of the possibility of creating nulls in the radiation pattern of an overlapped subarrayed antenna by placing nulls in the subarray pattern. The overlapped subarray antenna was discussed in detail in Fante<sup>1</sup>; it was shown there that this system has great potential for low-sidelobe wideband scanning. We also briefly discussed the possibility of controlling the subarrays so as to produce pattern nulls. Here we will enlarge upon that discussion.

### 2. THEORETICAL DISCUSSION

The basic configuration, which is shown in Figure 1, uses a circular lens fed by a hybrid matrix. When an input port (on face A) is excited, a distinct subarray distribution is produced on the output face (plane C) of the lens. Exciting a different port produces a different subarray pattern, which overlaps the first. We can apply different time delays to each subarray simply by applying different time

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(Received for publication 4 April 1980)

1. Fante, R.L. (1979) Study of the Radiation Properties of Overlapped Subarrayed Scanning Antennas, RADC-TR-79-293.

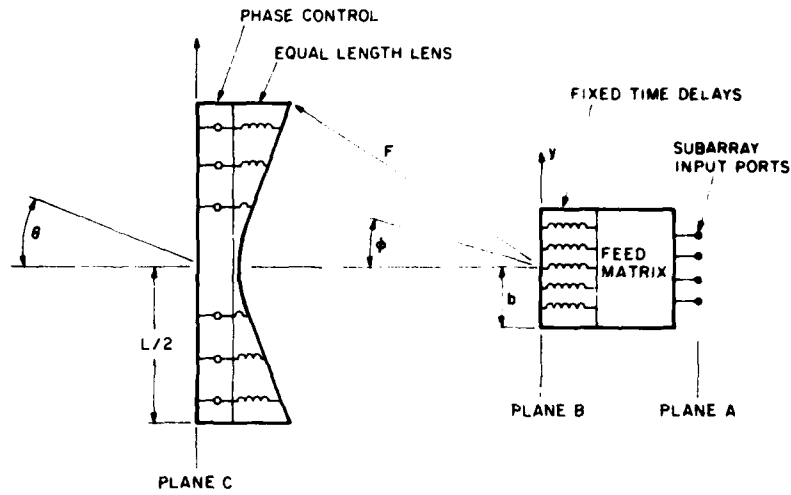


Figure 1. Overlapped Subarrayed Antenna System

delays to each input port. It is this feature which gives the system its large bandwidth.

In Fante<sup>1</sup> it was shown that the radiation pattern  $F(S)$  of this system is given by

$$F(S) = C_1 \int_{-1}^1 d\eta a(\eta) G[(1-R)S_0 - \gamma R \beta \eta] \cdot \text{sinc} \left[ \pi \ell \gamma R \left( \eta + \frac{RS - S_0}{\gamma R} \right) \right] \quad (1)$$

where  $a(\eta)$  is the distribution of the excitation on face B of the feed array;  $R = \lambda_0/\lambda$ ,  $\lambda_0$  is the midband wavelength,  $\lambda$  is the operating wavelength;  $\ell = L/D$ ,  $L$  is the lens width,  $D$  is the separation between subarray centers on face C;  $S = (D/\lambda_0) \sin \theta$ ,  $S_0 = (D/\lambda_0) \sin \theta_0$ ,  $\theta_0$  is the scan angle;  $\gamma = (bD/\lambda_0 F)$ ,  $F$  is the focal length of the main lens,  $2b$  is the width of the feed array (face B);  $\beta = 1$  if the feed is a true time-delay system and  $\beta = \lambda/\lambda_0$  if the feed is a Butler matrix. Also  $G(S)$  is the radiation pattern corresponding to the input distribution on the feed and is defined as

$$G(S) = \sum_{p=-M+1}^M \hat{I}_p e^{i2\pi(p-1/2)S} \quad (2)$$

where  $\hat{I}_p$  is the excitation on the  $p^{\text{th}}$  input port, and we have assumed  $2M$  input ports.

If the lens were very large ( $l \rightarrow \infty$ ) it is readily shown (for  $\beta = 1$ ) that Eq. (1) reduces to

$$F(S) \simeq G[R(S - S_0)] a \left[ \frac{RS - S_0}{\gamma R} \right] \quad (3)$$

so that, in this limit, the system radiation pattern is simply the product of the unsquinted feed pattern  $G[R(S - S_0)]$  and the (squinted) distribution on face B of the array.

From Eq. (3) we see that if we could put a null of fractional width  $\delta$  in the distribution  $a(\eta)$  it would appear directly as a null of width  $\epsilon = \gamma\delta$  in the radiation pattern  $F(S)$ . Consequently we could place nulls in the radiation pattern  $F(S)$  by placing nulls in  $a(\eta)$ . This situation is illustrated graphically in Figure 2, for the case  $\lambda = \lambda_0$ .

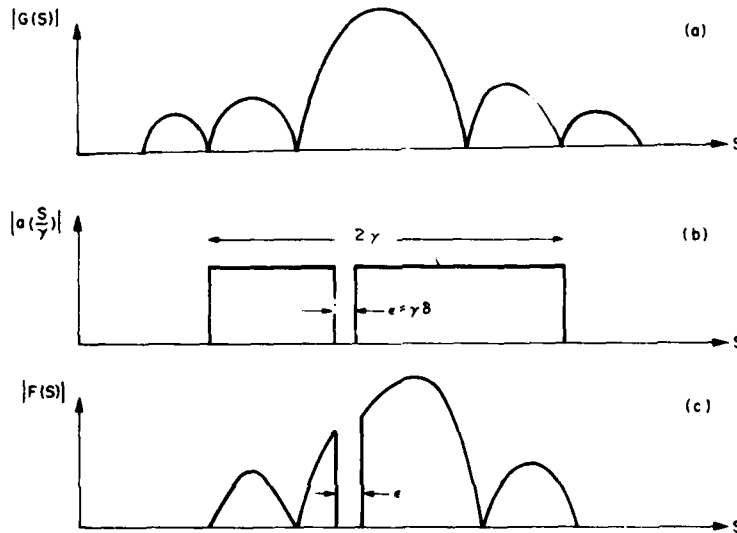


Figure 2. Subarray Nulling for an Infinite Lens ( $L \rightarrow \infty$ )

Unfortunately, in a realistic system the lens width  $L$  is finite and the actual radiation pattern is the convolution of Eq. (3) and a sinc function. For example, at midband ( $\lambda = \lambda_0$ ) we can rewrite Eq. (1) as

$$F(S) = C_2 \int_{-\gamma}^{\gamma} dt K(t) \text{sinc}[\pi t(t - (S - S_0))] \quad (4)$$

where

$$K(t) = a\left(\frac{t}{\gamma}\right) G(t) \quad (5)$$

In writing Eq. (4) we have assumed that  $a(-\eta) = a(\eta)$ . The physical meaning of Eq. (4) is illustrated in Figure 3. Note that the notch in the radiation pattern in Figure 2c is filled in by finite-lens diffraction effects in Figure 3c. From Figure 3 it is also evident that in order to reproduce the null in  $a(\eta)$  in the radiation pattern, we require that the width  $2/l$  of the sinc function be less than the null width  $\epsilon$ . Consequently a necessary condition for a well-defined null is that

$$\epsilon l \gg 1 \quad (6a)$$

or equivalently

$$\gamma \delta l \gg 1 \quad (6b)$$

where  $\epsilon$  is the null width of the ideal ( $l \rightarrow \infty$ ) system in S-space and  $\delta/2$  is the fractional portion of face B which is nulled.

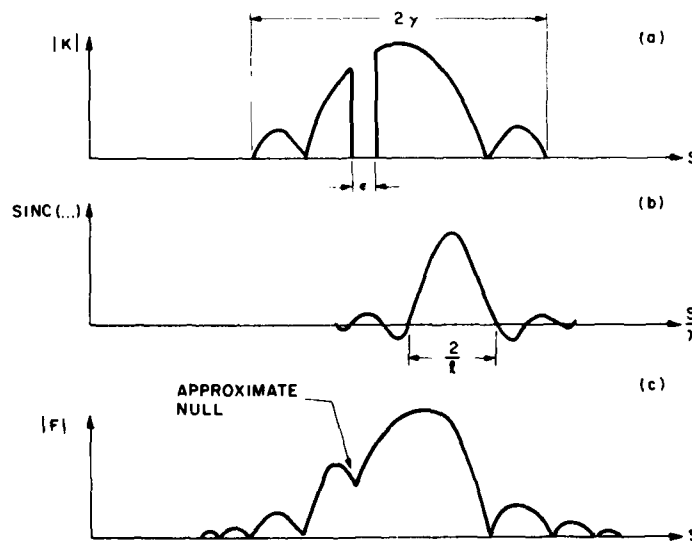


Figure 3. Effect of Subarray Nulling for a Finite Lens

### 3. NUMERICAL RESULTS

In this section we will present computed radiation patterns for some realistic systems. In the last section we treated face B of the feed as a continuum, whereas in reality face B consists of  $2N$  discrete radiators, as shown in Figure 4. We shall assume that these radiators are separated by a distance  $\Delta$  and have the (complex) excitations  $\{a_n\}$  for  $-N + 1 \leq n \leq N$ . In all cases studied in this report we shall also assume that  $2M = 16$ , so that there are 16 overlapped subarrays across the lens. Finally we have defined  $\gamma_0 = \Delta D / \lambda_0 F$ .

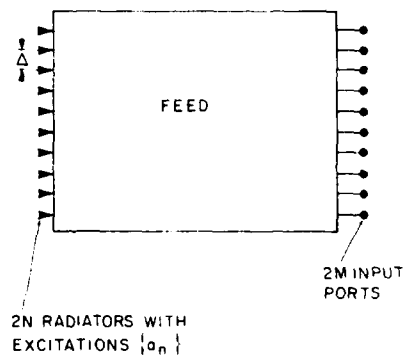


Figure 4. Magnified Version of the Feed

We shall first study the effect of simply setting several of the  $\{a_n\}$  equal to zero while keeping all the others equal to unity. In Figure 5 we show the result at midband for  $2N = 32$  when we attempt to place a null at  $S - S_0 = -0.02$  by setting  $a_0 = a_1 = a_2 = 0$ , but keeping  $a_{-15}$  through  $a_{-1}$  and  $a_3$  through  $a_{16}$  equal to unity, for the case when  $l = 16.4$  (so that the lens is slightly larger than the width of the 16 overlapped subarrays). We note that the desired null actually splits into two distinct deep nulls (depth greater than  $-70$  dB) with a  $-38$  dB hump in the middle, so that there is no true notch. There are two other important points to note. The gain at  $S - S_0 = 0$  (where in a real radar system the target would be located) is reduced by  $-25$  dB and the system sidelobes have been increased by approximately  $13$  dB. Consequently, for a lens with  $l = 16.4$  it does not make too much sense to attempt to place nulls too close to the center of the main beam.

In Figure 6 we show what happens when we move the null further from the center of the main beam (to  $S - S_0 = -0.035$ ). In this case the gain at  $S - S_0 = 0$  is reduced by only  $7$  dB and the sidelobes increased by only  $8$  dB, relative to the

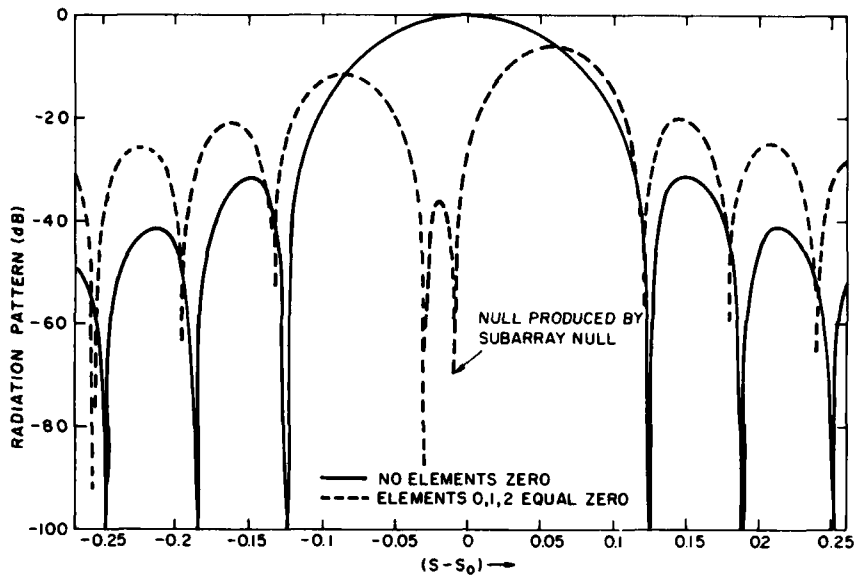


Figure 5. Effect of Attempting to Place a Null at  $S - S_0 = -0.02$  by Setting Elements 0, 1, and 2 on Face B Equal to Zero

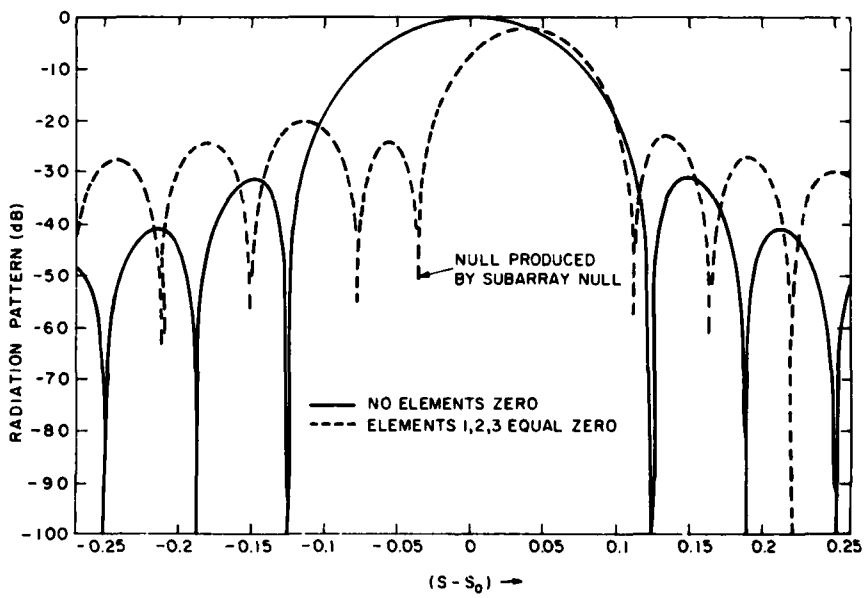


Figure 6. Effect of Attempting to Place a Null at  $S - S_0 = -0.035$  by Setting Elements 1, 2, and 3 on Face B Equal to Zero

case when there is no main-beam null. When the null is moved further out to  $S - S_0 = -0.06$  the gain at  $S - S_0 = 0$  is only -2 dB and there is then a 6-dB increase in the sidelobe levels, as is evident from Figure 7. As the null is moved to still further positions from the center of the main beam there is essentially no gain loss at  $S - S_0 = 0$ , nor any increase in the sidelobe levels, as we can see from Figures 8 and 9.

One point clearly evident from Figures 6 to 9 is that the null is very narrow and is consequently narrow band.\* One would expect that the null region could be broadened by increasing the lens size  $l$  because then the radiation pattern would be a more faithful reproduction of  $K = aG$ , as we see from Figure 3. In Figure 10 we compare the null at  $S - S_0 = -0.06$  for the case when  $l = 16.4$  with that for  $l = 32$ . For  $l = 32$  the null begins to approximate a notch, but with a -28 dB hump in the middle. The magnitude of this hump is decreased as  $l$  is increased. For  $l = 40$ , the hump maximum has been lowered to -38 dB, and for  $l = 50$  the hump maximum is -48 dB. Consequently, for large enough  $l$  the pattern begins to exhibit a true notch.

Unfortunately, making  $l = L/D$  large is not a very practical solution for obtaining a null with a large instantaneous bandwidth, because it requires making the lens much wider than the region occupied by the illumination from the 16 overlapped subarrays. This means that the lens needs many extra phase shifters without a corresponding decrease in beamwidth. This situation is shown pictorially in Figure 11.

We have also studied methods for moving the position of the null. This is readily achieved by controlling the element excitations on face B of the feed. This is illustrated by the results in Figure 12. For example, a null at  $S - S_0 = -0.0745$  can be obtained by setting  $a_3 = 0.9$ ,  $a_4 = a_5 = a_6 = a_7 = 0$ ,  $a_8 = 0.1$  and all the other  $a_n$  equal to unity. This null can be moved to  $S - S_0 = -0.0735$  by setting  $a_3 = 0.8$ ,  $a_4 = a_5 = a_6 = a_7 = 0$ ,  $a_8 = 0.2$  and all other  $a_n$  equal to unity. We can also compensate for changes in operating frequency by varying the  $\{a_n\}$ . In Figure 13 we show what happens to a main-beam null as the frequency is changed but all  $\{a_n\}$  are kept constant. We note that a 1 percent frequency change results in a considerable null displacement. Thus, the pattern gain in the direction of a jammer at  $S - S_0 = -0.06$  would be -60 dB at  $f = f_0$  (midband) but would be only -18 dB at  $f = 1.01 f_0$ . However, as can be seen from Figure 14 it is possible to change the excitations  $\{a_n\}$  so as to keep the null in the same direction at two different frequencies. Thus, although the null has only a 0.3 percent instantaneous

\* For example, the fractional bandwidth for a -40-dB null is of order  $W/S_0$  where  $W$  is the -40-dB null width. From Figures 7 to 9 we see that  $W \approx 0.003$  so that for large scan angles ( $S_0 \approx 1.5$ ) the fractional bandwidth is of order of 0.2 percent.

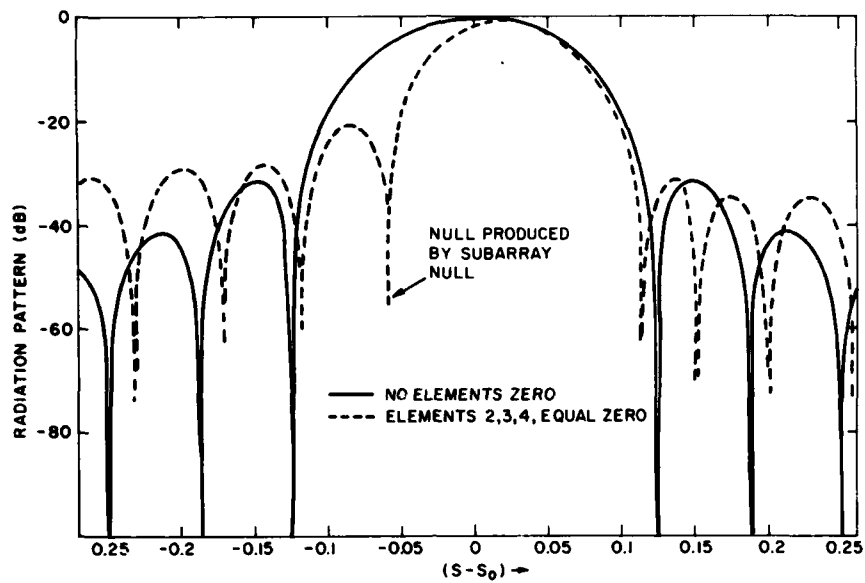


Figure 7. Effect of Attempting to Place a Null at  $S - S_0 = -0.06$  by Setting Elements 2, 3, and 4 on Face B Equal to Zero

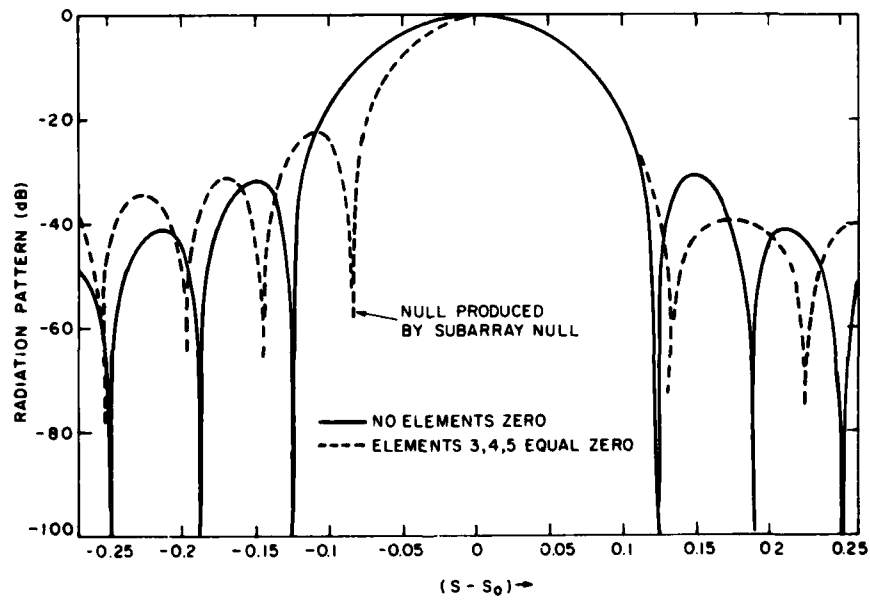


Figure 8. Effect of Attempting to Place a Null at  $S - S_0 = -0.085$  by Setting Elements 3, 4, and 5 on Face B Equal to Zero

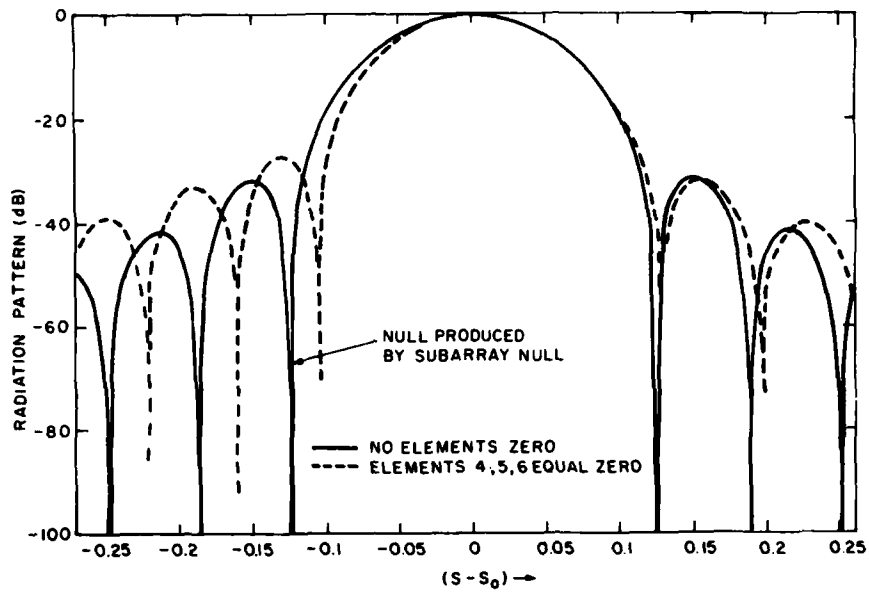


Figure 9. Effect of Attempting to Place a Null at  $S - S_0 = -0.105$  by Setting Elements 4, 5 and 6 on Face B Equal to Zero

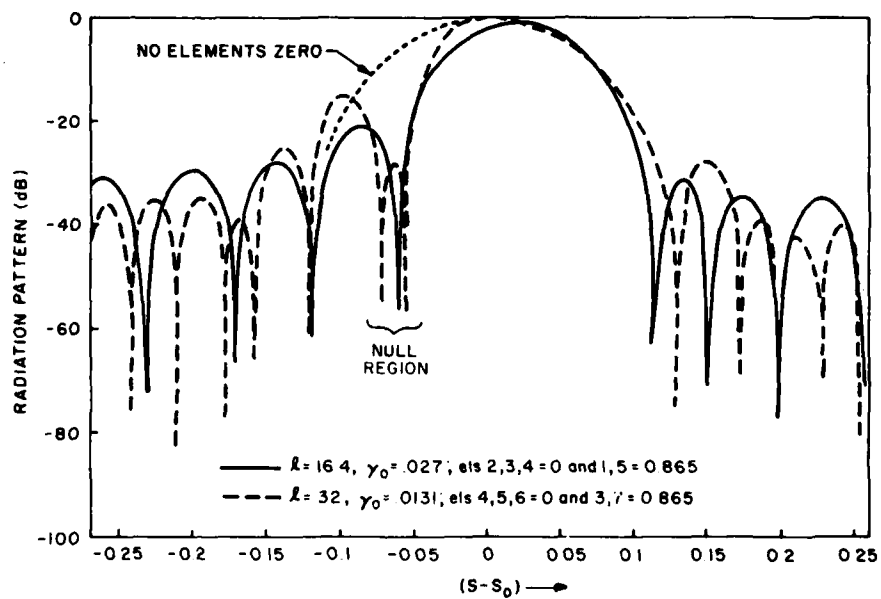


Figure 10. Effect of Increasing Lens Size  $l$  in Order to Broaden the Null at  $S - S_0 = -0.06$

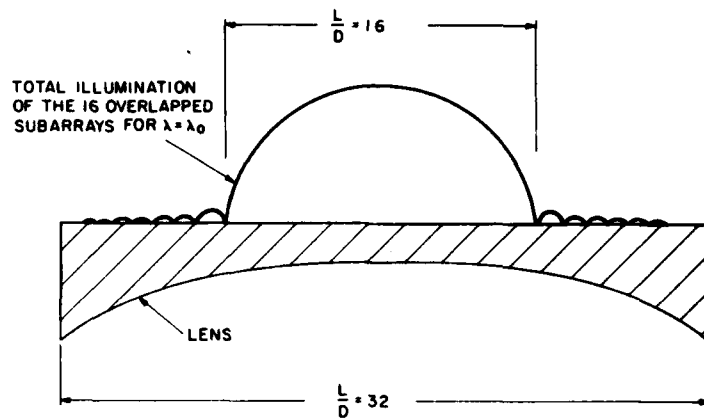


Figure 11. Illustration of the Illumination on the Lens When  $l = L/D$  is Much Larger than the Number of Subarrays ( $2M$ )

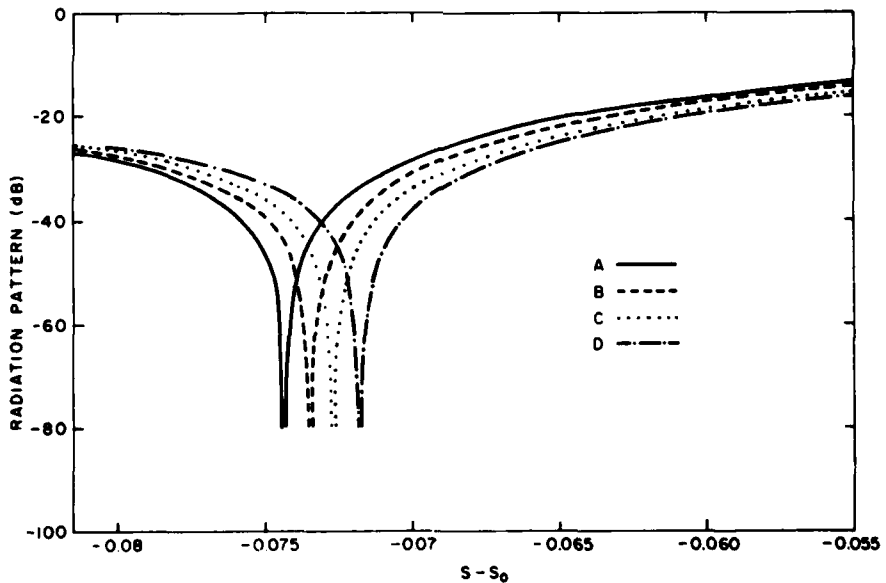


Figure 12. Use of Element Excitations to Control Null Placement for  $l = 16.4$ ,  $\gamma_0 = 0.0135$ ,  $R = 1$ ,  $2N = 64$ ,  $2M = 16$  and Elements 4 Through 7 on Face B Equal to Zero. Also: A)  $a_3 = 0.9$ ,  $a_8 = 0.1$ , B)  $a_3 = 0.8$ ,  $a_8 = 0.2$ , C)  $a_3 = 0.7$ ,  $a_8 = 0.3$ , D)  $a_3 = 0.6$ ,  $a_8 = 0.4$

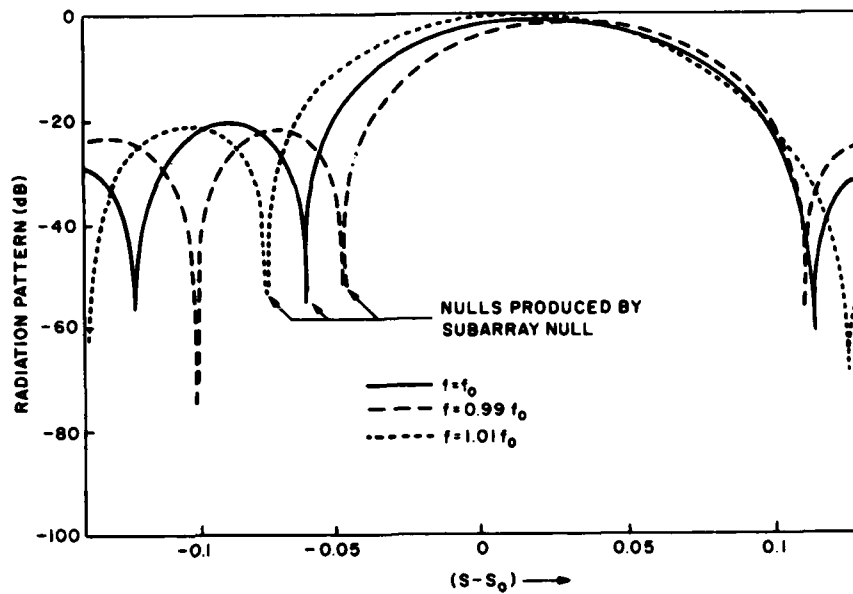


Figure 13. Effect of Varying Frequency on the Null Position When  $l = 16.4$ ,  $\gamma_0 = 0.027$ ,  $2M = 16$ ,  $2N = 32$ ,  $S_0 = 1.5$ , and Elements 2, 3, and 4 on Face B are Equal to Zero

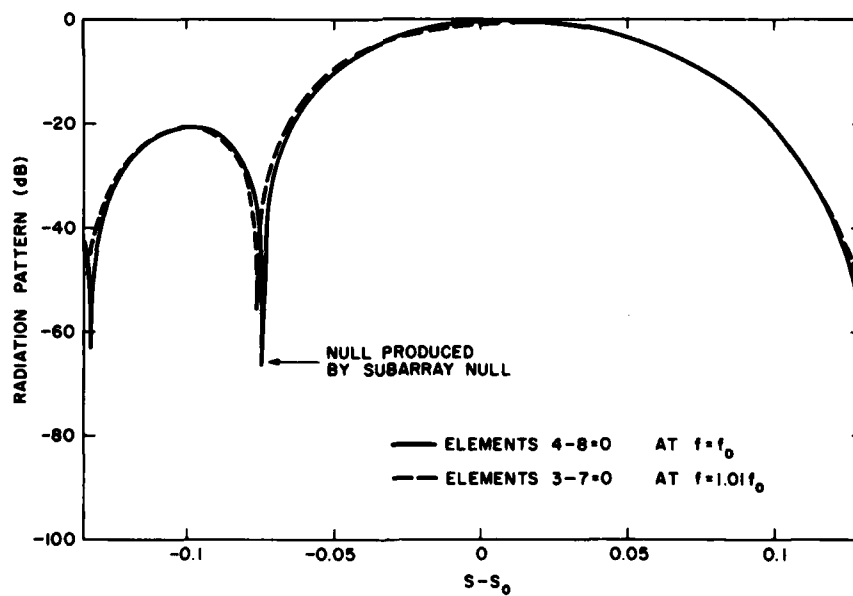


Figure 14. Use of Element Switching to Maintain a Null at the Same Position as the Frequency Is Changed, for the Case When  $l = 16.4$ ,  $\gamma_0 = 0.0135$ ,  $2N = 64$ ,  $2M = 16$ , and  $S_0 = 1.5$

bandwidth, it can have a much broader bandwidth when used in a frequency-hopping system since we can program the excitation coefficients  $\{a_n\}$  so that they are switched to a new set  $\{a'_n\}$  each time the frequency hops to a new value.

An alternate approach to ameliorate the deleterious effects of a jammer has been suggested by Mailloux.<sup>2</sup> In his technique one does not attempt to place a single null (or notch) at the jammer location, but rather null-out nearly one entire half of the beam. This concept is illustrated in Figure 15, for the ideal case of an infinite lens ( $L \rightarrow \infty$ ). Such a system is inherently wideband, as we can see from the pictorial representations in Figure 16, for three frequencies  $f = f_0$ ,  $f = f_0 + \Delta f$  and  $f = f_0 - \Delta f$ . Unfortunately in a realistic system, in which the lens width  $L$  is finite, we cannot duplicate the behavior shown in Figure 15. In Figure 17 we show the radiation pattern at midband when one half of the elements on face B are set equal to zero (that is, we set  $a_1$  through  $a_{16}$  equal to zero and  $a_{-15}$  through  $a_0$  equal to unity). We note that, because of finite-lens effects the radiation pattern is not zero for  $S - S_0 < 0$ , although it is below what would be present if no elements were set equal to zero. In addition, the gain loss at  $S - S_0 = 0$  (target location) is nearly 5 dB and the sidelobe levels are increased by approximately 10 dB (relative to the case when no elements are nulled). We might expect to make the pattern for  $S - S_0 < 0$  a better approximation to the ideal pattern (see Figure 15) by tapering the distribution of the  $a_n$ 's as shown in Figure 18. The effect of this taper is shown in Figure 19. We note that the taper improves the pattern for  $S - S_0 < 0$  only slightly, but does produce a noticeable lowering of the sidelobe levels. Furthermore, we do not get any significant further improvement in the pattern by tapering both sides of the  $\{a_n\}$  distribution as shown in Figure 20.

Clearly, the approximation of the realistic pattern to the ideal one becomes better as  $l = L/D$  is increased. In Figures 21 and 22 we show the patterns for the case when  $l = 32$ . In Figure 21 we have used the taper  $\exp(-0.25 n^2)$  on the  $\{a_n\}$  for  $n \geq 0$  and the results in Figure 22 correspond to a taper  $\exp(-0.125 n^2)$  for  $n \geq 0$  with all other  $a_n = 1$ . We note that the taper  $\exp(-0.125 n^2)$  gives quite reasonable results (we also tried numerous other tapers but  $\exp(-0.125 n^2)$  was about the best). In fact we can see how much improvement there is over the case when  $l = 16.4$  by comparing the results for  $l = 16.4$  with those for  $l = 32$ . This is done in Figure 23. We note that for  $l = 32$  the pattern is below -40 dB for all  $S - S_0 \leq -0.06$ , and this is very much better than the results for  $l = 16.4$ .

There is, of course, one major flaw in increasing lens size to improve the approximation to the ideal; since we are making the lens large, why not use the whole lens and not just part of it in the first place? This would give a pattern only half as wide in  $S - S_0$  space so that jammers inside the main beam would be

2. Mailloux, R.J. (1980) private communication.

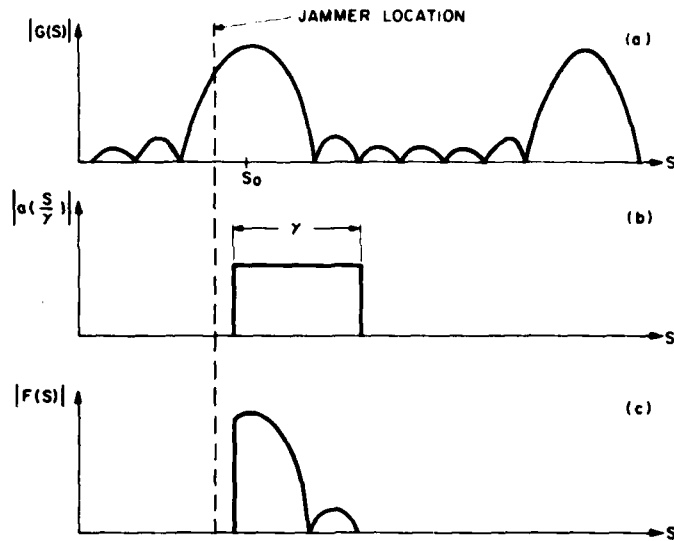


Figure 15. Effect of Setting Nearly One Half of the Subarray Pattern Equal to Zero (for  $L \rightarrow \infty$ )

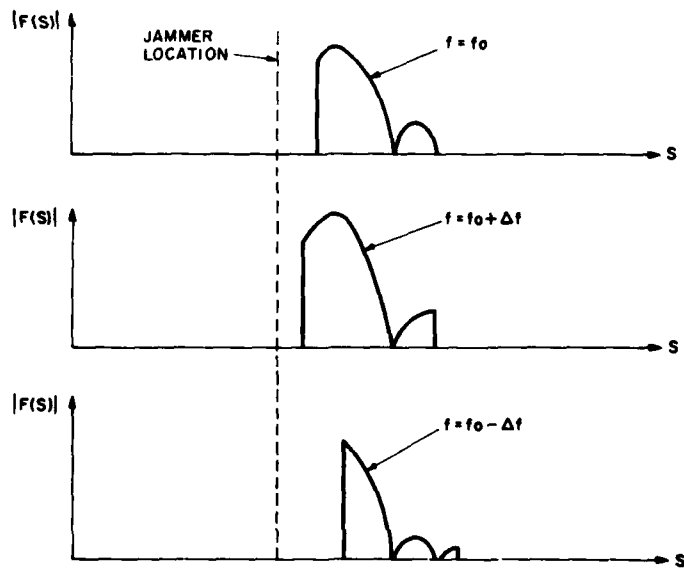


Figure 16. Effect of Changing Frequency on the Ideal System Depicted in Figure 15

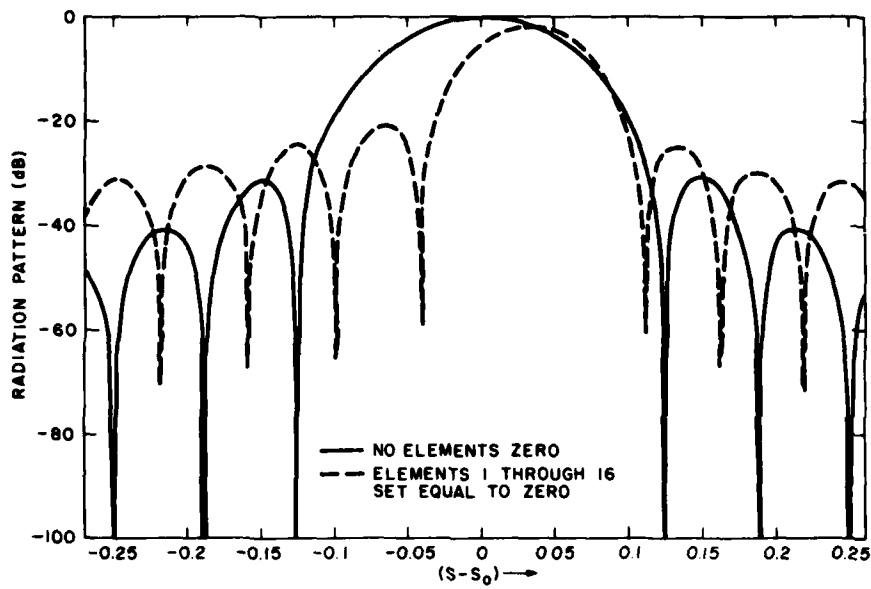


Figure 17. Effect on the Radiation Pattern Setting Half of the Elements on Face B Equal to Zero, for the Case When  $l = 16.4$ ,  $\gamma_0 = 0.027$ ,  $2M = 16$ ,  $2N = 32$ , and  $R = 1$

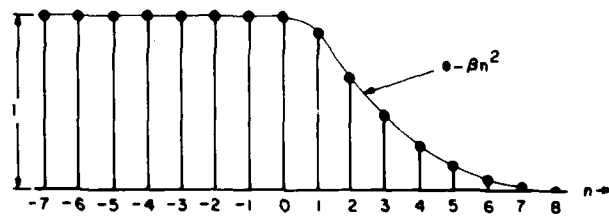


Figure 18. Values of  $a_n$  vs  $n$  for the Case When  $2N = 16$

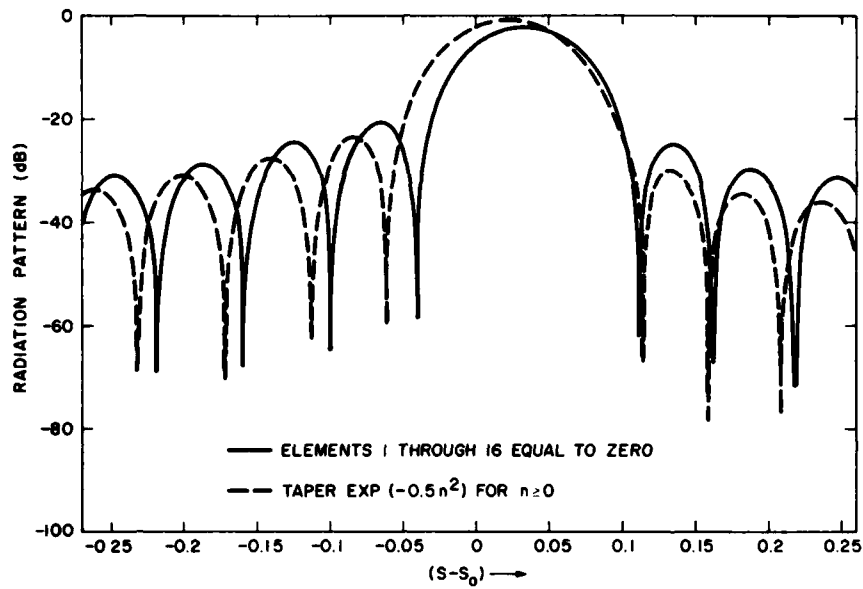


Figure 19. Effect of a Taper on Face B on the Radiation Pattern for the Case When  $l = 16.4$ ,  $\gamma_0 = 0.027$ ,  $2M = 16$ ,  $2N = 32$ , and  $R = 1$

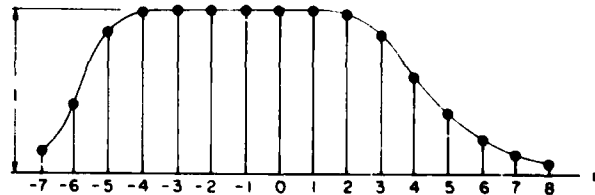


Figure 20. Typical Case When the Distribution of the  $a_n$  Is Tapered at Both Ends

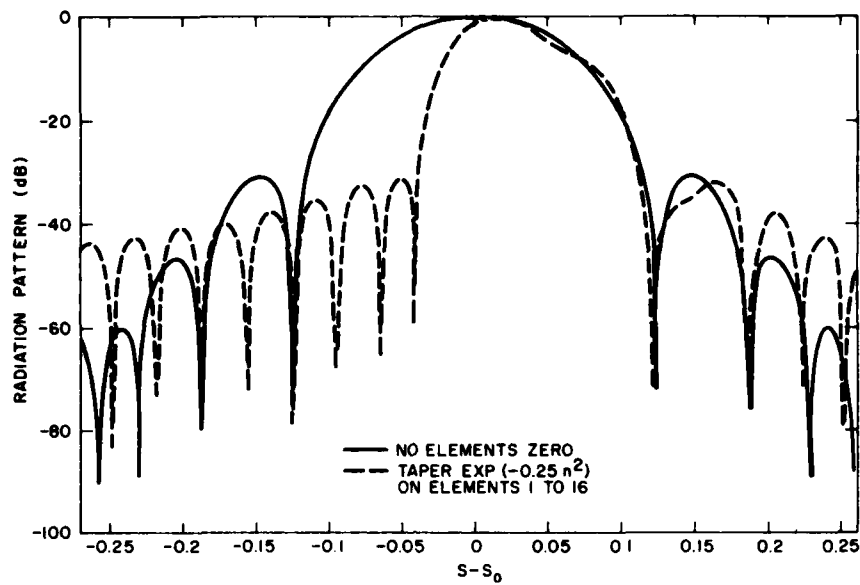


Figure 21. Effect on the Radiation Pattern of Placing a Taper  $\exp(-0.25 n^2)$  on Elements 1 Through 16 on Face B, Assuming  $l = 32$ ,  $R = 1$ ,  $2N = 32$ ,  $2M = 16$ , and  $\gamma_0 = 0.0131$

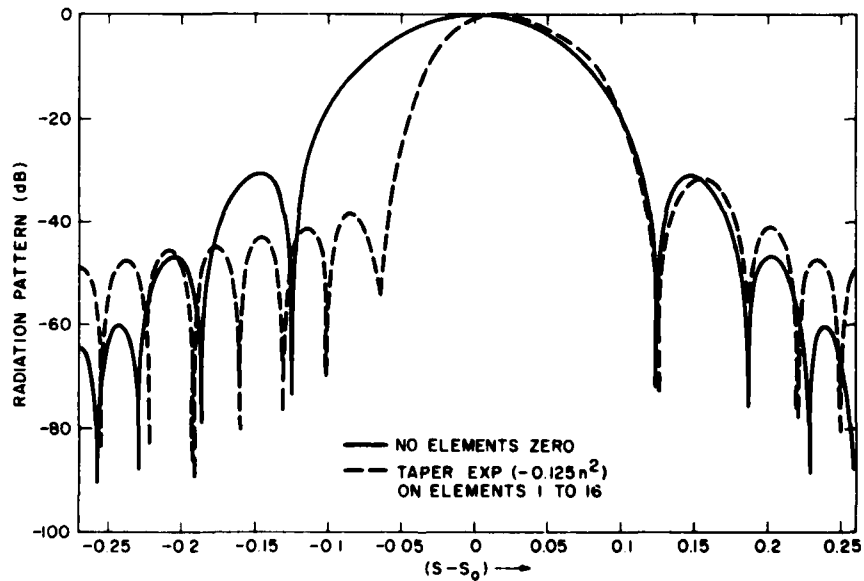


Figure 22. Effect on the Radiation Pattern of Placing a Taper  $\exp(-0.125 n^2)$  on Elements 1 Through 16 on Face B, Assuming  $l = 32$ ,  $R = 1$ ,  $2N = 32$ ,  $2M = 16$ , and  $\gamma_0 = 0.0131$

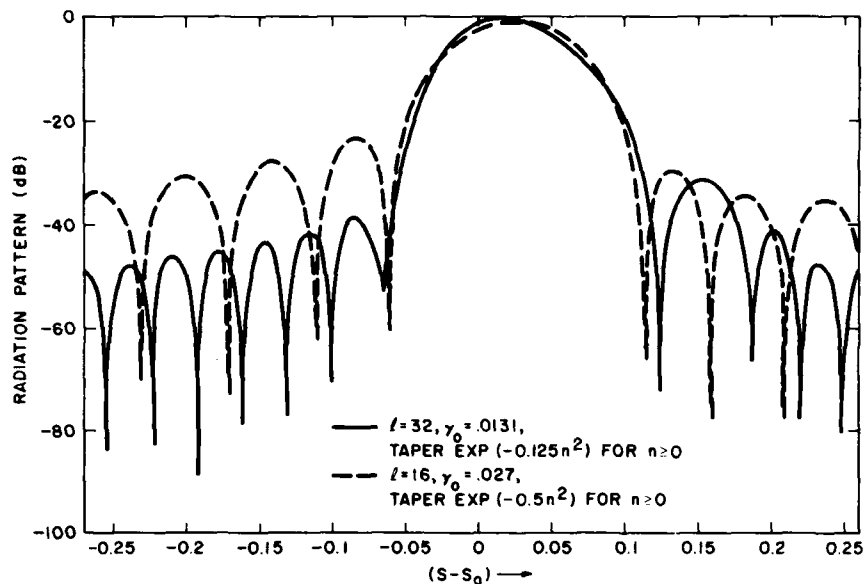


Figure 23. Effect of Lens Size on the Radiation Pattern of a System in Which One Half of the Elements on Face B Are Tapered

outside the narrowed beam corresponding to the lens twice as wide. Thus, this scheme gives wide bandwidth, but at the expense of a large lens. It is essentially the same problem we ran into earlier when attempting to place a notch in the main beam.

#### 4. CONCLUSIONS

We have studied the possibility of placing nulls in the main beam of the overlapped subarrayed antenna by controlling the excitation of the elements on face B of the feed in Figure 1. We have found that it is possible to place a null in the main beam by setting the excitation on several of the elements on face B equal to zero, but that such nulls are extremely narrow band (about 0.3 percent instantaneous bandwidth) under normal conditions. We have found that it is possible to produce wideband nulls with this method but at the expense of increasing the lens size (while keeping the number of subarrays constant) relative to the subarray spacing ( $l$  large). We have also studied the possibility of tapering half the elements on face B towards zero so as to produce an entire null region over half of the main beam. This method is somewhat successful but in order to get deep wideband nulls we again are forced to make  $l$  large.

We have not studied the possibility of null control by controlling the excitations at both face A and face B as shown in Figure 24, but this is an intriguing possibility. Perhaps with control at both faces, a null of wider bandwidth can be produced.

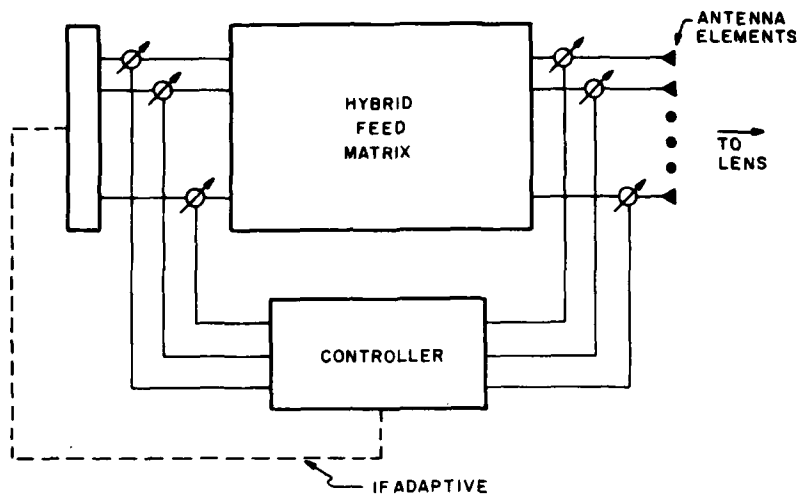


Figure 24. Control of Excitations at Both Input and Output Ports

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